**Title:** Simultaneous Oscillation and Frequency Tracking of Multiple Resonances Via Digitally Implemented Phase-Locked Loop Array

**Abstract:**
Systems and Methods for controlling one or more mechanical resonators and determining information from resonant shift of the resonator(s) behavior, including at least one mechanical resonator, an excitation element for driving the resonator(s), a sensor for monitoring the motion of the resonator(s), at least one phase locked loop (PLL) in feedback between the excitation and monitoring elements, wherein each PLL is configured to operate at or near a different resonant mode of the resonator(s), and a processor for determining information from PLL internal signals indicative of a resonator frequency shift.

**Diagram:**
[Diagram of a phase-locked loop system]
Figure 1

Figure 2
1. COS output automatic frequency gain control KI OX) S Kp (x) -> CC filter error adjustable phase delay

Figure 3

Figure 4

1st mode \( Q = 3620 \)
2nd mode \( Q = 7290 \)
3rd mode \( Q = 7340 \)
4th mode \( Q = 7770 \)

Relative frequency deviation from \( \omega_0 \)
Figure 5

Figure 6
Figure 7

Optical readout system

Piezoresistive readout system

Figure 8a

Figure 8b
Simultaneous transit
Example A

Simultaneous transit
Example B

Figure 11a

Figure 11b
Figure 12
Flowing a fluid through at least one mechanical resonator carrying a fluid channel 1301

Driving the resonator(s) with an excitation element 1302

Sensing the motion of the resonator(s) 1303

Operating at least one phase locked loop (PLL) in feedback between the excitation and monitoring elements, wherein each PLL is configured to operate at or near a different resonant bending mode of the resonator(s) 1304

determining the position and mass of particles flowing through the channel on the resonator(s) from PLL internal signals indicative of the resonator frequency shift due to the particles' mass and position 1305

Figure 13
SIMULTANEOUS OSCILLATION AND FREQUENCY TRACKING OF MULTIPLE RESONANCES VIA DIGITALLY IMPLEMENTED PHASE-LOCKED LOOP ARRAY

CROSS-REFERENCE TO RELATED APPLICATIONS

[0001] This application claims priority to U.S. Provisional Application Ser. No. 62/069,793 filed Oct. 28, 2014, which is incorporated by reference in its entirety.

BACKGROUND

[0002] This application relates to controlled oscillation of resonators and in particular to digitally implemented Phase-Locked Loop (PLL) control of Suspended MicroChannel Resonators (SMR’s).

[0003] SMR’s are developing uses in medical and industrial applications requiring the rapid characterization of substances suspended in fluids. Increased automation and high throughput requirements for some SMR applications may benefit from improved techniques for oscillation control and resonant shift detection for SMR’s.

SUMMARY

[0004] In some embodiments a control system and methods for operating one or more SMR’s includes a digitally implemented PLL operating as a feedback loop between the excitation and motion sensing elements of an SMR system allowing for precise and tailored control of SMR oscillation and resonant shift detection.

[0005] In some embodiments, a system may be provided for controlling one or more mechanical resonators and determining information from the resonator(s) behavior, including at least one mechanical resonator, an excitation element for driving the resonator(s), a sensor for monitoring the motion of the resonator(s), at least one phase locked loop (PLL) in feedback between the excitation and monitoring elements, wherein each PLL is configured to operate at or near a different resonant mode of the resonator(s), and a processor for determining information from PLL internal signals indicative of a resonator frequency shift.

[0006] In some embodiments, a method may be provided for controlling one or more mechanical resonators and determining information from the resonator(s) behavior, including driving the resonator(s) with an excitation element, sensing the motion of the resonator(s), operating at least one phase locked loop (PLL) in feedback between the excitation and monitoring elements, wherein each PLL is configured to operate at or near a different resonant mode of the resonator(s), and determining information from PLL internal signals indicative of a resonator frequency shift.

[0007] In some embodiments, the PLL’s may be implemented in digital logic.

[0008] In some embodiments, the PLL’s may be implemented on a Field Programmable Gate Array (FPGA).

[0009] In some embodiments, the transfer function of each resonator-PLL feedback loop may be configurable for desired characteristics including shape and bandwidth.

[0010] In some embodiments, the system may be configured to determine a 1-dimensional mass distribution from a resonant shift due the presence of a carried substance on the resonator.

[0011] In some embodiments, an array of resonators may be operated together.

[0012] In some embodiments, the array size may be one of 1 or more resonators, 10 or more resonators, or 50 or more resonators.

[0013] In some embodiments, the resonant frequencies of the resonators may be separated by at least 2 kHz.

[0014] In some embodiments, the resonator frequency may be between 30 kHz and 10 MHz.

[0015] In some embodiments, the resonator dimensions range from 10 microns to 1000 microns in length and from 1 to 100 microns in cross section.

[0016] In some embodiments, the mechanical resonator may be a suspended resonator.

[0017] In some embodiments the suspended resonator may be at least one of a cantilever resonator with a fixed end and a free end or a membrane resonator with at least two attachment regions.

[0018] In some embodiments, the suspended resonator may carry a fluid channel.

[0019] In some embodiments the system may include fluidic control elements for flowing suspended particles in the fluid channel and the information determined from the resonant shift includes mass and position of the particles.

BRIEF DESCRIPTION OF THE DRAWINGS

[0020] Aspects and advantages of the embodiments provided herein are described with reference to the following detailed description in conjunction with the accompanying drawings. Throughout the drawings, reference numbers may be re-used to indicate correspondence between referenced elements. The drawings are provided to illustrate example embodiments described herein and are not intended to limit the scope of the disclosure.

[0021] FIG. 1 shows a simplified schematic of an illustrative embodiment.

[0022] FIG. 2 shows a linear phase model of a PLL and resonator according to an illustrative embodiment.

[0023] FIG. 3 is a block diagram of digital implementation of a PLL according to an illustrative embodiment.

[0024] FIG. 4 shows the amplitude and phase of the first four resonances of an SMR according to an illustrative embodiment.

[0025] FIG. 5 shows the expected and measured closed loop response of the first four modes according to an illustrative embodiment.

[0026] FIG. 6 shows an SMR layout and parts of measured frequency waveforms according to an illustrative embodiment.

[0027] FIG. 7 is an illustration of spaced resonant frequencies for an array of suspended fluid channel resonators according to an illustrative embodiment.

[0028] FIGS. 8a and 8b show example optical and piezoresistive setups for operating many cantilevers according to an illustrative embodiment.

[0029] FIG. 9 shows a schematic of an exemplary system implemented FPGA’s according to an illustrative embodiment.

[0030] FIGS. 10a and 10b show frequency and position signals in four modes from a single 150 nm gold nanoparticle transiting an SMR according to an illustrative embodiment.
FIGS. 11a and 11b show frequency and position signals in four modes two nanoparticles transiting an SMR according to an illustrative embodiment. FIG. 12 shows frequency signals measured from a 12-cantilever SMR array according to an illustrative embodiment. FIG. 13 is a flow chart of an illustrative method. FIGS. 14a, 14b and 14c depict various suspended resonator characteristics.

DETAILED DESCRIPTION

Generally described, aspects of the present disclosure relate to resonators produced using fine scale microfabrication techniques for the structure, channels and in some cases actuators. Microfabrication may include patterning, etching, deposition, injection and related processes on such materials as glass, metals, plastics and crystalline materials such as silicon and silicon derivatives. Drivers, PLL’s, and other elements may include electronic circuits made from electrical components including resistors, capacitors, transistors, logic elements and the like which also may be fabricated onto application specific circuits and/or made up of discrete components in any combination.

One or more embodiments described herein may provide well controlled actuation and detection arrays of resonators, enabling the design of high-throughput parallel or series measurement systems based on suspended resonator technology.

One or more embodiments described herein may provide for precise shaping of the control signals for suspended resonators.

Mechanical resonators carrying fluid channels, for some cases known as suspended micro or nano channel resonators (SMR, SNR, used interchangeably herein) may be desirable for measuring properties such as the mass of objects that pass through the resonator. Various fluid channel resonators are described in the incorporated references attached hereto. These devices generally may include a fluidic device in which objects pass along a resonator that is oscillating. As an object moves along the resonator, the resonant frequency changes, enabling the measurement of properties such as mass of the object. Such resonators may be used to analyze the properties of cells or other particles.

Micro- and nano-mechanical resonators are extremely sensitive to external perturbations such as weak forces, electrical or magnetic fields and mass changes due to their high quality factors and minuscule sizes. Monitoring the oscillation frequency of such a resonator in one or more vibrational modes is a technique for detecting and quantifying these tiny perturbations. Using multiple mechanical resonators on a single device or single resonators in multiple vibration modes provides improved throughput and/or added functionality for the measurements of interest. Arrays of resonators for measuring growth rates of cells are described in U.S. Pat. No. 9,134,295, commonly owned with this application, and incorporated by reference. A scalable, high precision technique with controllable bandwidth may be desirable for simultaneously oscillating and monitoring a large number of resonances.

Resonator systems in some cases may utilize self-excitation loops for operation. Self-excitation loops, where the motion of the resonator is amplified, delayed, and fed back as the excitation signal, keep the resonator oscillating at its resonant frequency at all times, and provide high bandwidth measurements. However, when applied to multiple resonances with a single summed output, e.g., multiple modes of a resonator, it may be difficult to optimize the phase-shift and vibration amplitude for the individual modes, which may be desirable for minimizing the noise and precisely measuring resonance frequencies. Therefore, achieving sustained oscillations at multiple resonances may require the detection of the motion of each resonance, independent processing of each resonance signal and simultaneous excitation of the resonances. This may be advantageous for either observing multiple resonant modes for a single resonator, or observing resonant modes from multiple resonators with common excitation, or a combination of the two.

Controlling multiple modes may be accomplished by assigning a dedicated phase-locked loop (PLL) 1 for each resonance (FIG. 1). For the highest precision, the PLL gain parameters are set such that the resonator (1)-PLL(2) system (in closed-loop) has a desired response to changes in resonant frequency—for example, parameters for a Butterworth-type response are given in Table 1. This approach can be used to achieve an arbitrary transfer function (Chebyshev, elliptical, Dessel, etc) at a desired order and bandwidth or any transfer function with the desired shape and bandwidth. In general it may be desirable to set the transfer function of the PLL to be relatively flat up to a desired frequency, and rapid roll-off between successive frequencies of interest, i.e. other resonator frequencies or other mode frequencies. However other transfer functions may be of interest as well.

TABLE 1

<table>
<thead>
<tr>
<th>n</th>
<th>k_3</th>
<th>k_4</th>
<th>τ_1</th>
<th>τ_2</th>
</tr>
</thead>
<tbody>
<tr>
<td>1</td>
<td>β</td>
<td>k_5^2</td>
<td>1</td>
<td>1</td>
</tr>
<tr>
<td>2</td>
<td>β^2V^2</td>
<td>k_5^2</td>
<td>V^2/2β</td>
<td>V^2/2β</td>
</tr>
<tr>
<td>3</td>
<td>β^2V^2</td>
<td>k_5^2</td>
<td>(1 + j)/2β</td>
<td>(1 + j)/2β</td>
</tr>
</tbody>
</table>

For engineering the closed loop transfer function, the phase-domain transfer function of a harmonic oscillator around its resonant frequency is derived and used to calculate the transfer function of a generic resonator-PLL system (FIG. 2). Then, the PLL parameters (Table 1) are calculated that simplify the resonator-PLL system to a Butterworth filter with desired bandwidth, β, and order, n. The required PLL parameters for a desired order and bandwidth depend on the time constant, τ (a function of frequency and quality factor) of the corresponding resonance and the desired measurement bandwidth.

A desirable aspect of the technique is scalability. Analog PLL systems are generally not easily scaled, but an exemplary PLL may be digitally implemented on a field-programmable gate array (FPGA) (FIG. 3). Thus up to N PLLs may be implemented with similar effort as implementing one PLL, where N depends on the number of logic elements and other resources of the FPGA. In two exemplary implementations, an Altera Cyclone IV FPGA and an Altera Stratix IV FPGA were used, yielding N=12 and N=62, respectively. Larger FPGAs may allow for simultaneous measurement of hundreds of resonators.

An illustrative PLL element may be implemented including a phase-error detector, implemented as a multiplier followed by a second-order cascaded integrator-comb
(CIC) low-pass filter with variable rate change factor. CIC filters are very efficient to represent in digital logic, and thus help ensure that many PLLs can fit on a single FPGA. The CIC output is normalized relative to the input signal magnitude (calculated onboard in a manner analogous to a lock-in amplifier) such that it represents only the phase error and not the amplitude of the input signal. This phase error signal may then be passed through a configurable set of second order section (SOS) biquad filters and then used both for proportional and integral control of the frequency of a numerically controlled oscillator (NCO). The NCO output is then shifted by an arbitrary phase before being passed to the drive electronics. This phase shift may be chosen to maximize the oscillation amplitude of the resonator, or minimize the noise present in the loop. The output can also be arbitrarily rescaled to drive the resonator at chosen amplitude.

[0045] The PLL parameters (CIC filter rate, SOS filter parameters, proportional gain, integral gain, phase shift, drive amplitude) are not necessarily hardcoded into the FPGA code, but also can be both read and written by an on-FPGA CPU (implemented here as the NIOS II processor from Altera). In this embodiment, a CPU opens a socket for Ethernet-based communication with a PC, or other computing device, where the data can be stored and analyzed. The PC also can request that the on-FPGA CPU change these control parameters on the fly.

[0046] Communication between the FPGA and the PC may be either Ethernet, via TCP (setting parameter values) and UDP (the PC receiving frequency data from the FPGA). In this example over 100,000 32-bit frequency values per second may be sent without any lost data, and further compression of the frequency data via schemes like delta encoding could increase this bandwidth.

[0047] Because the PC can control the PLL parameters, the entire setup process can be easily automated such that a resonator system’s transfer function is measured, resonances are detected and Qs are calculated, and then the PLL parameters are automatically set to obtain any arbitrary transfer function for each resonator (for example, one might desire that all resonators behave identically, with flat frequency responses up to a fixed bandwidth).

[0048] Analog-to-digital and digital-to-analog conversion is done at 100 MHz with 14-bit converters in this example. The exemplary system is theoretically applicable for resonances up to 50 MHz, but practically probably below 25 MHz. The only requirements are that the resonator signal can be converted to an electrical signal (by any of a variety of means including optical levers, piezoresistors, capacitive sensors), and that the electrical drive signal from the FPGA can be converted to a driving force on the resonator (by any of a variety of means including piezoelectric, electrostatic, thermal, magnetic actuation).

[0049] The exemplary control system was tested in two ways: first using a suspended nanochannel resonator (SNR) in multiple modes simultaneously, and second in an array of 12 suspended microchannel resonators (SMRs) on a single chip. SNRs are high-quality-factor cantilevers with integrated fluidic channels that have been previously utilized to weigh nanoparticles. Different from the mass sensors operating by adsorption, SNRs weigh flowing particles in solution. Each particle generates a frequency modulation signal, which is a function of particle buoyant mass and flow path in the SNR. Therefore, monitoring position and mass of nanoparticles in real-time in an SNR may require not only oscillating multiple modes simultaneously, but also doing so with wide bandwidth and high precision.

[0050] The exemplary digital control system was tested with an SNR in feedback with four PLLs simultaneously. The lowest four mode frequencies were measured and corresponding Q-factors (FIG. 4) for calculating the PLL coefficients (Table 1) to achieve the desired first-order transfer functions (FIG. 5). Then 100 and 150 nm gold nanoparticles are flowed through the SNR, while recording the mode oscillation frequencies (FIG. 6). The signals observed from nanoparticles transit the SNR match exceedingly well with those predicted by theory, indicating that the exemplary PLL array provides high-bandwidth, low-noise, and low-distortion measurements of the resonant frequencies of each mode. Since the presented system is highly scalable, this same approach can be applied for any system with multiple resonances at different frequencies.

[0051] A second test of the exemplary control system was operating an array of resonators with different resonant frequencies (FIG. 7). The resonators are configured such that a single actuator (here, a single piezoceramic placed underneath the chip) is used to oscillate all of the resonators, and a single detector (in this embodiment, a photodetector 4) receives the superposition of all of the resonators’ positions (FIG. 8a). The resonators fluid channels may be configured in any desired pattern (serial, parallel, etc), but here were connected serially. In the test discussed here, the 12 cantilevers were fluidically connected in parallel, but simultaneously measured and oscillated in parallel. FIG. 9 therefore shows the frequency response of all 12 cantilevers, in which a series of cells and particles sequentially flows through each cantilever, one after another. As shown in FIG. 8b, in some embodiments a piezoresistive motion readout system may be employed as the readout mechanism.

[0052] In both 8a and 8b, the position signals from all resonators are combined into a single physical (voltage) signal. In the exemplary embodiment shown in 8a, a single light source (4) is used to illuminate all resonators in an array (here arrayed side-by-side (21)) simultaneously. The reflected light is diverted towards a single photodetector, which measures effectively the superposition of all resonator position signals. Similarly, in the exemplary embodiment shown in 8b, many resonator piezoresistors are initially combined in series (as shown) or in parallel, or any arrangement in which their total resistance is approximately a linear combination of all the individual resonator piezoresistor resistances. This combined resistance is used as one edge of a wheatstone bridge (5) and then amplified, yielding a signal analogous to the optical signal in 3a—that is, a superposition of all the resonators’ position signals. The array of PLLs on the FPGA then demodulate each resonator’s frequency signal individually (as they are all at different frequencies), and each PLL generates a sinusoidal drive signal at the resonance frequency of its corresponding resonance. The PLL outputs are collectively summed on the FPGA, and then used to drive a single actuator, in this embodiment, a piezoceramic, but might also include electrostatic or optical excitation methods.

[0053] The resonators described herein and in the incorporated references may be designed for measurements of individual particles or other objects that may be difficult to measure with conventional instrumentation. Thus the resonators are generally small enough that they are made with
Microelectronic Mechanical Systems (MEMS) microfabrication techniques. Mechanical resonators suitable for embodiments described herein fall into classes of dimensions suitable for the type targeted particle masses detectable: Exemplary classes include devices at large, medium, and small scales, and all three of these classes may be used in cantilever arrays and/or for multiple-mode operation.

**[0054]** Large (LSMR):

- a. cantilever cross section typically around 19×57 um, internal channels are 15×20 um.
- b. typical lengths of 200-500 um.
- c. Detectable mass—on the order of 0.1 pg or so, but typically we use these to measure yeast or mammalian cells, with buoyant masses from 5-500 pg.

**[0058]** Medium (mMSMR):

- a. cantilever cross section typically around 4×19 um, internal channels are 3×5 um.
- b. typical lengths of 100-400 um.
- c. Detectable mass—on the order of 0.2 fg or so, typically used to detect bacteria with buoyant masses from 0.5 fg to 500 fg.

**[0062]** Small (suspended nanochannel resonator or SNR):

- a. cantilever cross section typically around 1×5 um, internal channels are 0.4×1 um.
- b. typical lengths of 20-200 um.
- c. Minimum detectable mass—on the order of 5-10 ag. Used to detect nanoparticles (virus, DNA origami, protein aggregates, liposomes, etc).

**[0066]** As can be seen the dimensions cover the range from 1 to 1000 microns in length and from 1 to 100 microns in cross section. These sizes, implemented in silicon and/or other microfabricatable materials lead to resonant frequencies in the 10’s of kilohertz up to 10’s of megahertz range. Improvements in microfabrication techniques may provide for even smaller and more sensitive measurements operating at higher resonant frequencies, but improvements in electronics will also allow for faster PLL operation. Thus the techniques disclosed herein are not intended to be limiting by the current performance metrics, but the exemplary classes show that the application include measurements not easily performed or in many cases not possible with other analytic techniques.

**[0067]** The techniques disclosed herein, as mentioned above, are suitable to arrays of resonators as well as single resonators, and may be desirable for the case where the arrays of resonators are operated with some combination of common excitation and/or signal detection. As shown in FIG. 7, the individual resonators in an array may be fabricated with different lengths or cross sections, yielding a different resonant frequency for each resonator. FIG. 7 shows the transfer function for the sum of the resonators in a 12-cantilever array, in which cantilevers range from 350 to 450 um long. For this arrangement, it may be convenient as shown in FIG. 8 to excite the array with a common actuator 2 as shown, and observe the movement of the resonators with a common detector, 4 or 5. In this arrangement, the excitation and detector signals may be used in combination with individual PLL’s 1 as shown in FIG. 9, each with a transfer function with center frequency and band tailored to the resonant frequency of each resonator in the array. If the spacing of the resonant frequencies is chosen wide enough to accommodate the change in resonant frequency due to the transit of masses of interest in each resonator, then the system can ensure that every resonator is always vibrating at its resonant frequency, even if that resonant frequency is rapidly changing (e.g. a particle passing through a the channel on the resonator).

**[0068]** Some examples of resonator array systems would be measurement bandwidth goals: on the order of 100-1000 Hz per resonator, so spacing on the order of at least 2 kHz, with conservative current designs are on the order of 30 kHz as shown in FIG. 7.

**[0069]** Target resonator numbers: example designs with up to 12 cantilevers on a single chip have been tested, and designs with 40 cantilevers on a chip have been fabricated. 100 plus cantilevers are possible with current fabrication and FPGA implemented PLL control.

**[0070]** Using the frequency signal from multiple resonator modes measured simultaneously, one can estimate the position of point masses flowing through the resonator. FIG. 10a shows the resonant frequency signals for the first four bending modes of a 200-microns-long suspended nanochannel resonator, as a single 150 nm gold nanoparticle flowed through the resonator. FIG. 10b demonstrates the ability to use this frequency information to estimate the particle position (here the particle flows to the tip of the cantilever and then back to the base of the cantilever).

**[0071]** FIGS. 11a and 11b demonstrates that using multiple modes, even if there are multiple point masses loading the resonator simultaneously, they can be resolved using multiple modes. Examples A(11a) and B(11b) are two separate instances in which two nanoparticles nearly simultaneously transit the SNR nanochannel, yet their positions and masses can be precisely estimated (middle panels, and shown schematically in bottom panels).

**[0072]** FIG. 12 demonstrates the ability of the PLL array to simultaneously acquire resonant frequency data from 12 SMRs arrayed on a single chip. Frequency signals are shown after conversion from frequency(Hz) to mass (pg, 1 picogram=10^-12 g) such that they are directly comparable from each resonator. Each downward spike is a single cell transiting an SMR in the array. In the array employed here, the SMRs are fluidically connected in series, therefore each subsequent SMR measures nearly the same signal as the previous SMR, but at a slightly later point in time.

**[0073]** FIG. 13 is a flowchart of a method embodiment. Step 1301 includes flowing a fluid through at least one mechanical resonator carrying a fluid channel. Step 1302 includes driving the resonator(s) with an excitation element. Step 1303 includes sensing the motion of the resonator(s). Step 1304 includes operating at least one phase locked loop (PLL) in feedback between the excitation and monitoring elements. wherein each PLL may be configured to operate at or near a different resonant bending mode of the resonator(s), and Step 1305 includes determining the position and mass of particles flowing through the channel on the resonator(s) from PLL internal signals indicative of the resonator frequency shift due to the particles’ mass and position.

**[0074]** Although the illustrative embodiments thus far described have referred to suspended resonators carrying a fluid channel, the techniques disclosed are applicable to any mechanical resonator with suitable driving and motion sensing elements. Suspended resonators, particularly arrays of such resonators, may benefit from these control techniques. As shown in FIG. 14a, suspended resonators 2 may take the form of a cantilever with a fixed and a free end as already described, or may take the form of a suspended membrane resonator, 2, suspended at two, FIG. 14a, or more, FIG. 14b,
attachment regions. Such suspended resonators may carry fluid channels as described above or may be solid and/or have non-fluid channel sample holders, adsorption sites, traps, or other means of carrying a substance of interest. Substances carried by these resonators, including particles flowing in fluid channels for suitable resonators, adsorbed particles or others, will affect the resonant behavior of the resonator. Measuring the resonant shift due to the presence of carried substances may provide information about the properties of the carried substances. Mass and position information about carried substances is one example. Other effects may affect the resonant behavior of resonators. Depending on their configuration, resonators may be sensitive to forces, electrical and magnetic fields, temperature changes and other effects, any of which may cause a resonant shift for suitably configured resonators. The control techniques described herein may benefit any measurement of the behavior of a resonator due to effects that cause a resonant shift.

[0075] The embodiments described herein are exemplary. Modifications, rearrangements, substitute processes, etc. may be made to these embodiments and still be encompassed within the teachings set forth herein. One or more of the steps, processes, or methods described herein may be carried out by one or more processing and/or digital devices, suitably programmed.

[0076] Depending on the embodiment, certain acts, events, or functions of any of the embodiments described herein can be performed in a different sequence, can be added, merged, or left out altogether (e.g., not all described acts or events are necessary for the practice of the embodiment). Moreover, in certain embodiments, acts or events can be performed concurrently, e.g., through multi-threaded processing, interrupt processing, or multiple processors or processor cores or on other parallel architectures, rather than sequentially.

[0077] The various illustrative logical blocks, modules, analog electronics and method steps described in connection with the embodiments disclosed herein can be implemented as electronic hardware, computer software, or combinations of both. To clearly illustrate this interchangeability of hardware and software, various illustrative components, blocks, modules, and steps have been described above generally in terms of their functionality. Whether such functionality is implemented as hardware or software depends upon the particular application and design constraints imposed on the overall system. The described functionality can be implemented in varying ways for each particular application, but such implementation decisions should not be interpreted as causing a departure from the scope of the disclosure.

[0078] The various illustrative logical blocks and modules described in connection with the embodiments disclosed herein can be implemented or performed by a machine, such as a processor configured with specific instructions, a digital signal processor (DSP), an application specific integrated circuit (ASIC), a field programmable gate array (FPGA) or other programmable logic device, discrete gate or transistor logic, discrete hardware components, or any combination thereof designed to perform the functions described herein. A processor can be a microprocessor, but in the alternative, the processor can be a controller, microcontroller, or state machine, combinations of the same, or the like. A processor can also be implemented as a combination of computing devices, e.g., a combination of a DSP and a microprocessor, a plurality of microprocessors, one or more microprocessors in conjunction with a DSP core, or any other such configuration. For example, functions allocated to device identified as “PC” may be implemented using a discrete memory chip, a portion of memory in a microprocessor, flash, EEPROM, or other types of memory, or computing device.
recited devices. Such one or more recited devices can also be collectively configured to carry out the stated recitations. For example, "a processor configured to carry out recitations A, B and C" can include a first processor configured to carry out recitation A working in conjunction with a second processor configured to carry out recitations B and C.

While the above detailed description has shown, described, and pointed out novel features as applied to illustrative embodiments, it will be understood that various omissions, substitutions, and changes in the form and details of the devices or algorithms illustrated can be made without departing from the spirit of the disclosure. As will be recognized, certain embodiments described herein can be embodied within a form that does not provide all of the features and benefits set forth herein, as some features can be used or practiced separately from others. All changes which come within the meaning and range of equivalency of the claims are to be embraced within their scope.

The following references are incorporated by reference in their entirety:


1. A system for controlling one or more mechanical resonators and determining information from the resonator(s) behavior, comprising:
   - at least one mechanical resonator,
   - an excitation element for driving the resonator(s),
   - a sensor for monitoring the motion of the resonator(s),
   - at least one phase locked loop (PLL) in feedback between the excitation and monitoring elements, wherein each PLL is configured to operate at or near a different resonant mode of the resonator(s), and;
   - a processor for determining information from PLL internal signals indicative of a resonator frequency shift.

2. The system of claim 1 wherein the PLL’s are implemented in digital logic.

3. The system of claim 2 wherein the PLL’s are implemented on a Field Programmable Gate Array (FPGA).

4. The system of claim 2 wherein the transfer function of each PLL is configurable for desired characteristics including shape and bandwidth.

5. The system of claim 4 wherein the system is configured to detect a 1-dimensional mass distribution from a resonant shift due the presence of a carried substance on the resonator.

6. The system of claim 1 wherein an array of resonators are operated together.

7. The system of claim 6 wherein the array size is one of 1 or more resonators, 10 or more resonators, or 50 or more resonators.

8. The system of claim 6 wherein the resonant frequencies of the resonators are separated by at least 2 kHz.

9. The system of claim 6 wherein the resonator frequency is between 30 kHz and 10 MHz.

10. The system of claim 6 wherein the resonator dimensions range from 10 microns to 1000 microns in length and from 1 to 100 microns in cross section.

11. A method for controlling one or more mechanical resonators and determining information from the resonator(s) behavior, comprising:
   - driving the resonator(s) with an excitation element,
   - sensing the motion of the resonator(s),
   - operating at least one phase locked loop (PLL) in feedback between the excitation and monitoring elements, wherein each PLL is configured to operate at or near a different resonant mode of the resonator(s), and;
   - determining information from PLL internal signals indicative of a resonator frequency shift.

12. The method of claim 11 wherein the PLL’s are implemented in digital logic.

13. The method of claim 12 wherein the PLL’s are implemented on a Field Programmable Gate Array (FPGA).

14. The method of claim 12 including configuring the transfer function of each PLL for desired characteristics including shape and bandwidth.

15. The method of claim 14, including determining a 1-dimensional mass distribution from a resonant shift due the presence of a carried substance on the resonator.

16. The method of claim 11 wherein an array of resonators are operated together.

17. The method of claim 16 wherein the array size is one of 1 or more resonators, 10 or more resonators, or 50 or more resonators.

18. The method of claim 16 wherein the resonant frequencies of the resonators are separated by at least 2 kHz.

19. The method of claim 16 wherein the resonator frequency is between 30 kHz and 10 MHz.

20. The method of claim 16 wherein the resonator dimensions range from 10 microns to 1000 microns in length and from 1 to 100 microns in cross section.

21. The system of claim 1 wherein the mechanical resonator is a suspended resonator.

22. The system of claim 21 wherein the suspended resonator is at least one of a cantilever resonator with a fixed end and a free end, or a membrane resonator with at least two attachment regions.

23. The system of claim 22 wherein the suspended resonator carries a fluid channel.

24. The system of claim 23 wherein the system includes fluidic control elements for flowing suspended particles in the fluid channel and the information determined from the resonant shift includes mass and position of the particles.

25. The method of claim 11 wherein the mechanical resonator is a suspended resonator.

26. The method of claim 25 wherein the suspended resonator is at least one of a cantilever resonator with a fixed end and a free end or a membrane resonator with at least two attachment regions.
27. The method of claim 26 wherein the suspended resonator carries a fluid channel.

28. The method of claim 27 comprising flowing suspended particles in the fluid channel and the information determined from the resonant shift includes mass and position of the particles.

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